

Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims:

1. (Currently Amended) A method of manufacturing an oxide superconductive wire, comprising:

the step of positioning a metal tape $[(6)]$ in a position at a distance (L) of at most 100 mm from a target $[(7)]$ for generating an oxide; and

the only one step of forming an oxide superconductive layer $[(12)]$ on said metal tape $[(6)]$ with one set of the target and laser light using a vapor deposition method while transferring said metal tape $[(6)]$ at a transfer speed of at least 5 m/h with keeping the distance $[(L)]$ between said metal tape $[(6)]$ and said target $[(7)]$ of at most 100 mm.

2. (Original) The method of manufacturing an oxide superconductive wire according to claim 1, wherein

said vapor deposition method is a pulsed laser deposition (PLD) method.

3. (Currently Amended) The method of manufacturing an oxide superconductive wire according to claim 1, wherein

said oxide superconductive layer $[(12)]$ is a rare-earth-barium-copper-based superconductive oxide (RE123; RE = rare-earth element, Y).